Faculty Position Opening at Hachinohe Institute of Technology

Ken-ichi Funazaki, President, Hachinohe Institute of Technology

We are seeking applicants for the faculty position described below.

1. Position and Number of Personnel

One position available for Professor, Associate Professor, Lecturer, or Assistant Professor.

2. Affiliation

Faculty of Engineering, Hachinohe Institute of Technology.

3. Area of Specialization (Expertise/Research Field)

The broad area of Information Science and Engineering, with a particular focus on fields such as Software Development, Networking, and Security.

4. Courses to be Taught

Programming-Related Subjects, Data Structures and Algorithms, Information Security, Software Development, Subjects related to System Development, Basic Experiments in Information Engineering, Specialized Information Seminar, Graduation Research, etc.

Note: The course names are current as of now. The name of the course may be changed to the same content upon appointment.

Note: Due to a planned faculty reorganization in the 2027 academic year (Reiwa 9), the affiliation may change, and the successful candidate may be required to teach courses other than those listed above.

5. Qualifications

(1) Must hold a Ph.D. (including those expected to obtain the degree by the time of appointment) or possess equivalent or superior research achievements and practical experience.

(2) Must have enthusiasm for research, education, and university management, and be proactive in collaborating with the local community.

(3) Must be willing to conduct education and research based on the university's Founding Spirit and Educational Philosophy, and demonstrate enthusiasm for guiding students.

(4) Must possess the Japanese language ability necessary to perform the duties.

(5) Practical experience in a corporation or similar organization will be taken into consideration.

6. Date of Appointment

April 1, 2026 (Reiwa 8)

7. Employment Status

Full-time (A probationary period of up to one year will be set in accordance with the corporation's "Rules of Employment".)

8. Required Application Documents

(1) Curriculum Vitae (Use a commercially available form, with the applicant's signature, academic history from high school graduation onward, attached photograph, and email address.)

(2) Statement of Professional Experience

(3) List of Educational and Research Achievements (A4 size, free format: include peer-reviewed original papers, international conference papers, reviews/commentaries, invited lectures, books, reports, patents, works, qualifications obtained, current research or professional activities, academic society activities, etc.)

(4) Summary Description of 5 to 7 Major Achievements from the list above (If a paper, a separate print or copy is acceptable.)

(5) Track Record of External Research Funding Acquisition, such as competitive research grants (Classify as Principal Investigator and Research Collaborator.)

(6) Statement of Research Achievements and Future Research Plan upon appointment (Must be written in Japanese, approximately 2,000 characters, on no more than two A4 pages.)

(7) Statement of Educational Achievements and Aspirations upon appointment (Must be written in Japanese, approximately 1,000 characters, on no more than one A4 page.)

(8) Record of Social Activities

9. Application Deadline

Friday, October 31, 2025 (Reiwa 7)

10. Selection Process

(1) First Screening (Document Review): Results will be notified around early November.

(2) Second Screening (Interview): Travel and transportation expenses for the second screening will be borne by the applicant.

Note: Those who pass the first screening will be asked to submit letters of recommendation from individuals who can evaluate the applicant's qualifications, abilities, and personality. Please be advised of this requirement.

11. Document Submission and Contact Information

General Affairs Division, Hachinohe Institute of Technology

88-1 Oaza Myoaza Ohiraki, Hachinohe-shi, Aomori 031-8501, Japan

Please mark the envelope in red with "Information Science Faculty Application Documents Enclosed" and send it by registered mail (Kan'i Kakitome). Please note that application documents will generally not be returned.

Inquiries:
General Affairs Division
TEL: 0178(25)8021 (Direct Line)
FAX: 0178(25)2769
E-mail: soumu@hi-tech.ac.jp

12. Other
(1) Personal information provided in the application will be used solely for the purpose of personnel selection.
(2) The personal information of the successful candidate will continue to be used for employment management purposes. The personal information of other applicants will be disposed of responsibly after the completion of the selection process.